

	Type	Hits	Search Text	DBs
1	BRS	159411	solid adj state	USPAT; EPO; JPO; DERWENT; IBM_TDB
2	BRS	136881	semiconductor and laser	USPAT; EPO; JPO; DERWENT; IBM_TDB
3	BRS	840197	pump pumping pumped	USPAT; EPO; JPO; DERWENT; IBM_TDB
4	BRS	12158	YAG	USPAT; EPO; JPO; DERWENT; IBM_TDB
5	BRS	590	(solid adj state) and (semiconductor and laser) and (pump pumping pumped) and YAG	USPAT; EPO; JPO; DERWENT; IBM_TDB
6	BRS	65662	micrometer	USPAT; EPO; JPO; DERWENT; IBM_TDB
7	BRS	81	((solid adj state) and (semiconductor and laser) and (pump pumping pumped) and YAG) and micrometer	USPAT; EPO; JPO; DERWENT; IBM_TDB
8	BRS	65662	micrometer ".mu.m"	USPAT; EPO; JPO; DERWENT; IBM_TDB
9	BRS	0	".mu.m"	USPAT; EPO; JPO; DERWENT; IBM_TDB
10	BRS	135227	mu	USPAT; EPO; JPO; DERWENT; IBM_TDB
11	BRS	41297	mu adj m	USPAT; EPO; JPO; DERWENT; IBM_TDB
12	BRS	106742	micrometer (mu adj m)	USPAT; EPO; JPO; DERWENT; IBM_TDB
13	BRS	81	((solid adj state) and (semiconductor and laser) and (pump pumping pumped) and YAG) and (micrometer (mu adj m))	USPAT; EPO; JPO; DERWENT; IBM_TDB
14	BRS	9191	"1.064" "1064"	USPAT; EPO; JPO; DERWENT; IBM_TDB
15	BRS	28	((solid adj state) and (semiconductor and laser) and (pump pumping pumped) and YAG) and (micrometer (mu adj m))) and ("1.064" "1064")	USPAT; EPO; JPO; DERWENT; IBM_TDB
16	BRS	215	(solid adj state) and (semiconductor and laser) and (pump pumping pumped) and YAG and ("1.064" "1064")	USPAT; EPO; JPO; DERWENT; IBM_TDB
17	BRS	38399	(concave convex) and mirror	USPAT; EPO; JPO; DERWENT; IBM_TDB
18	BRS	6630	Nd and Tm	USPAT; EPO; JPO; DERWENT; IBM_TDB

	Type	Hits	Search Text	DBs
19	BRS	9	((solid adj state) and (semiconductor and laser) and (pump pumping pumped) and YAG and ("1.064" "1064")) and ((concave convex) and mirror) and (Nd and Tm)	USPAT; EPO; JPO; DERWENT; IBM_TDB